## WHAT IS CLAIMED IS:

- 1. A substrate cleaning tool for cleaning a substrate, comprising a plurality of thready brush members in a bundle, the brush members having channels formed therein for passage of cleaning liquid.
- 2. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are capable of ejecting the cleaning liquid through respective surfaces of the brush members.
- 3. A substrate cleaning tool as claimed in Claim 1, wherein the substrate cleaning tool is capable of rotating against the substrate.
  - 4. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are made of water permeable material and also shaped to be hollow.
  - 5. A substrate cleaning tool as claimed in Claim 2, wherein the brush members have a number of channels for passage of the cleaning liquid.
  - 6. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are formed so as to be water-repellent.
  - 7. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are formed so as to be hydrophilic.
  - 8. A substrate cleaning tool as claimed in Claim 1, wherein the brush members have their respective one ends tied up in a bundle.
  - 9. A substrate cleaning tool as claimed in Claim 8, wherein the brush members extend straingt.
  - 10. A substrate cleaning tool as claimed in Claim 8,

wherein the brush members have long elements and short elements.

- 11. A substrate cleaning tool as claimed in Claim 1, wherein the brush members have their respective both ends tied up in a bundle and also make loops.
- 12. A substrate cleaning tool for cleaning a substrate, comprising a plurality of thready brush members in a bundle, the brush members being formed so as to be water-repellent.
- 13. A substrate cleaning apparatus comprising:

a substrate cleaning tool having a plurality of thready brush members in a bundle, the brush members having channels formed therein for passage of cleaning liquid;

a scrub arm for holding the substrate cleaning tool;
and

a holder for holding a substrate to be cleaned by the substrate cleaning tool.

- 14. A substrate cleaning apparatus as claimed in Claim 13, wherein the scrub arm is provided with a driving mechanism for driving the substrate cleaning tool.
- 15. A substrate cleaning apparatus as claimed in Claim 14, wherein the driving mechanism moves the substrate cleaning tool up and down.
- 16. A substrate cleaning apparatus as claimed in Claim 14, wherein the driving mechanism rotates the substrate cleaning tool.
- 17. A substrate cleaning apparatus as claimed in Claim 14, wherein the driving mechanism moves the substrate cleaning tool up and down and also rotates the substrate cleaning tool.
- 18. A substrate cleaning apparatus as claimed in Claim 13,

wherein the holder holds the substrate rotatably.

19. A substrate cleaning apparatus as claimed in Claim 13, further comprising a nozzle for ejecting cleaning liquid for rinsing.